SEMICON Europa 2026 - Munich, Germany

This schedule is subject to change without notice.

Tuesday, November 10, 2026

MEETING LOCATION	7:00	8:00	9:00	10:00	11:00	12:00	13:00	14:00	15:00	16:00	17:00	18:00	19:00	20:00
ICM (Room: Staffelsee)			Mercury (HG) Replacement WG 09:00-10:00	Roughness (AFM & Haze) WG 10:00-11:00										

Wednesday, November 11, 2026

MEETING LOCATION	7:00	8:00	9:00	10:00	11:00	12:00	13:00	14:00	15:00	16:00	17:00	18:00	19:00	20:00
ICM (Room: Staffelsee)			Int'l Advanced Surface Inspection (TF) 09:00-10:00	Int'l Test Methods (TF) 10:00-11:00	Int'l Polished Wafer (TF) 11:00-12:00	Silicon Wafer GCS 12:00-13:00	Int' Advanced Wafer Geometry (TF) 13:00-15:00							

Thursday, November 12, 2026

MEETING LOCATION	7:00	8:00	9:00	10:00	11:00	12:00	13:00	14:00	15:00	16:00	17:00	18:00	19:00	20:00
ICM (Room: Staffelsee)			Silicon Wafer (TC) 09:00-11:00			Compound Semiconductor Materials (TF & TC) 11:15-13:00		Gases and Liquid Chemicals (TC) 14:00-15:00		*(By Invitation Only)* ERSC 15:30-17:00				
ICM (Room: 13a)			SEMI Global Standards Summit 9:00 -15:00											

Standards Summit
Compound Semiconductor Materials
Gases and Liquid Chemicals
Silicon Wafer
Closed Meeting